
OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Application Information**

Application Type:: Regular
Subject Matter:: Utility
CD-ROM or CD-R:: None
Title:: MALEIC ACID AND ETHYLENE UREA
CONTAINING FORMULATION FOR REMOVING
RESIDUE FROM SEMICONDUCTOR
SUBSTRATE AND METHOD FOR CLEANING
WAFER
Attorney Docket Number:: 117641
Suggested Drawing Figure::
Total Drawing Sheets::
Small Entity:: No

Applicant Information

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Tomoe
Family Name:: MIYAZAWA
City of Residence:: Funabashi-shi
Country of Residence:: JAPAN

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Yoichiro
Family Name:: FUJITA
City of Residence:: Funabashi-shi
Country of Residence:: JAPAN

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Ichiro
Family Name::	KOBAYASHI
City of Residence::	Funabashi-shi
Country of Residence::	JAPAN

Correspondence Information

Correspondence Customer Number:: 25944

Assignee Information	
Assignee Name::	NISSAN CHEMICAL INDUSTRIES, LTD.
Street of mailing address::	7-1, Kandanishiki-cho 3-chome, Chiyoda-ku,
City of mailing address::	Tokyo
Country of mailing address::	JAPAN
Postal or Zip Code of mailing address::	101-0054